

Docket No.: 60188-108

PATENT

#3
4-30-02 d
jc997 U.S. PTO
09/973888
10/11/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Kazuhiro OKABAYASHI, et al. :

Serial No.: :

Group Art Unit:

Filed: October 11, 2001 :

Examiner:

For: INTEGRATED CIRCUIT WITH MULTIPROCESSOR ARCHITECTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Michael E. Fogarty
Registration No. 36,139

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 MEF:prp
Date: October 11, 2001
Facsimile: (202) 756-8087

#3

INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 60188-108		SERIAL NO.	
				APPLICANT Kazuhiro OKABAYASHI, et al.			
				FILING DATE October 11, 2001		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	4,368,514	1/11/1983	Persaud et al.				
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			

1997 U.S. PTO
09/973888



EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.